

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|-------|--|--------------------|------------------|---------|------------------|
| L13 | 5 | ((("6541382") or ("6528384") or ("6498383") or ("6335235") or ("6103632")).PN. | US-PGPUB; USPAT | OR | OFF | 2005/08/10 16:58 |
| L14 | 35847 | (silicon adj nitride) and ((etching or removing or etch or etched) with substrate) and (resist or mask or photoresist) | US-PGPUB; USPAT | OR | ON | 2005/08/10 17:04 |
| L15 | 23322 | 14 and ((trench or opening or recess or aperture or depression or hole) with substrate) | US-PGPUB; USPAT | OR | ON | 2005/08/10 17:06 |
| L16 | 4368 | 15 and (semiconductor adj (layer or film)) | US-PGPUB; USPAT | OR | ON | 2005/08/10 17:06 |
| L17 | 3053 | 16 and @ad<"20021030" | US-PGPUB; USPAT | OR | ON | 2005/08/10 17:07 |
| L18 | 1166 | 17 and (nitride with mask) | US-PGPUB; USPAT | OR | ON | 2005/08/10 17:07 |
| L19 | 822 | 17 and (nitride near5 mask) | US-PGPUB; USPAT | OR | ON | 2005/08/10 17:07 |